

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	8171	wafer and electrostatic	USPAT	2003/04/28 08:51	
2	BRS	L2	816	semiconductor adj1 wafer and electrostatic adj1 (carrier or chuck)	USPAT	2003/04/28 08:55	
3	BRS	L3	1	semiconductor adj1 wafer and electrostatic adj1 carrier	USPAT	2003/04/28 08:55	
4	BRS	L4	688	semiconductor adj1 wafer and electrostatic adj1 chuck and method and process\$3	USPAT	2003/04/28 08:59	
5	BRS	L5	282	semiconductor adj1 wafer same electrostatic adj1 chuck and method same process\$3	USPAT	2003/04/28 09:00	
6	BRS	L6	0	semiconductor adj1 wafer same (movable or moving or transporting or transportable) adj2 electrostatic adj1 chuck and method same process\$3	USPAT	2003/04/28 09:01	